



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4164**
Tetsuroh NAKAMURA et al. : Attorney Docket No. 2005_0724A
Serial No. 10/533,132 : Group Art Unit 2875
Filed October 11, 2005 : Examiner Sarah Al-Hashimi

LIGHT SOURCE FOR IMAGE WRITING
APPARATUS, AND PRODUCTION
METHOD FOR LIGHT SOURCE

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

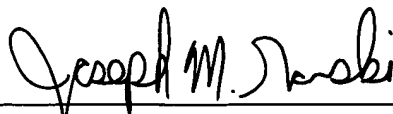
This is in response to the Restriction Requirement of July 21, 2006.

Applicants, by their undersigned representative, hereby elect the invention of Group I which is drawn to a light source for an image writing apparatus by claims 1-10 and 13-16.

Having made the required election, a full examination on the merits of the elected invention is hereby requested.

Respectfully submitted,

Tetsuroh NAKAMURA et al.

By: 
Joseph M. Gorski
Registration No. 46,500
Attorney for Applicants

JMG/nka
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
August 14, 2006